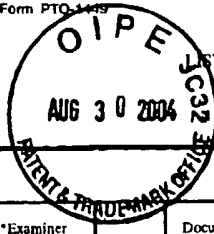

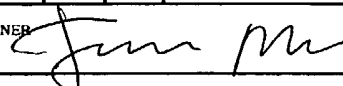


Form PTO-1449		U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE		ATTY. DOCKET NO. 30-5004DIV3		SERIAL NO. 09/912,616	
LIST OF ART CITED BY APPLICANT (Use several sheets if necessary)				APPLICANT Vladimir Segal et al.			
				FILING DATE July 24, 2001		GROUP 1742	
U.S. PATENT DOCUMENTS							
*Examiner Initial	Document Number	Date	Name	Class	Subclass	Filing Date If Appropriate	
AA							
FOREIGN PATENT DOCUMENTS							
Document Number	Date	Country	Class	Subclass	Translation		
AM	JP362089543A	04-1987	JP (abstract)	—	—	Yes	No
OTHER REFERENCES (including Author, Title, Date, Pertinent Pages, Etc.)							
AO	F. J. Humphreys et al., "Developing stable fine-grain microstructures by large strain deformation", Phil. Trans. R. Soc. Lond. A, June 15, 1999, Vol. 357 #1756, pp. 1663-1681.						
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EXAMINER <i>Jim</i>				DATE CONSIDERED 11/12/04			
*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.							

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Document Number	Date	Country	Class	Subclass	Translation		
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EXAMINER jm mm			DATE CONSIDERED 11/12/04				
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AM							
OTHER REFERENCES (including Author, Title, Date, Pertinent Pages, Etc.)							
	AO		V. M. Segal et al., "Processes of Plastic Structure Formation", Science and Engineering, 1994, published in Russia, Chapters 1, 3 and 4, with Statement in Accordance with 37 CFR 1.98(a)(3)(i).				
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